



PATENT APPLICATION
Docket No. 5484-048
Client No. PX828-US/SSD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup Shim and Yo-Ho Kim

Serial No. 09/305,240 Examiner: Nadav, Ori

Confirmation No. 1838

Filed: May 4, 1999 Group Art Unit: 2811

For: OPEN DRAIN INPUT/OUTPUT STRUCTURE AND
MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR
DEVICE

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Responsive to the Office Action dated March 26, 2004, enclosed is an amendment in the
above-identified application.

The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	25	16	90	x \$18 =	\$162
Independent Claims	5	5	0	x \$86 =	\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$162

*greater of twenty (20) or number for which fee has been paid

**greater of three (3) or number for which fee has been paid

- ☒ PTO Form 2038 authorizing credit card payment for the above-listed fees is enclosed.
☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Respectfully submitted,

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Li Mei Vermilya



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AMENDMENT

This paper is responsive to the non-final Office Action mailed 26 March 2004.

Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

An **Appendix** following page 16 of this paper contains the copyright page and pages 292-293 of Silicon Processing for the VLSI Era, Volume 3 – The Submicron MOSFET, by Stanley Wolf, Ph.D.

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